

Notice of References Cited

Application/Control No.

10/536,791

Applicant(s)/Patent Under
Reexamination
KIM ET AL.

Examiner

CATHERYNE CHEN

Art Unit

1655

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,776,460	07-1998	Kim et al.	424/728
	B	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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	N	JP 6321643	09-1988	Japan	Ishida et al.	-----
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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